

国立大学法人 京都大学 エネルギー理工学研究所

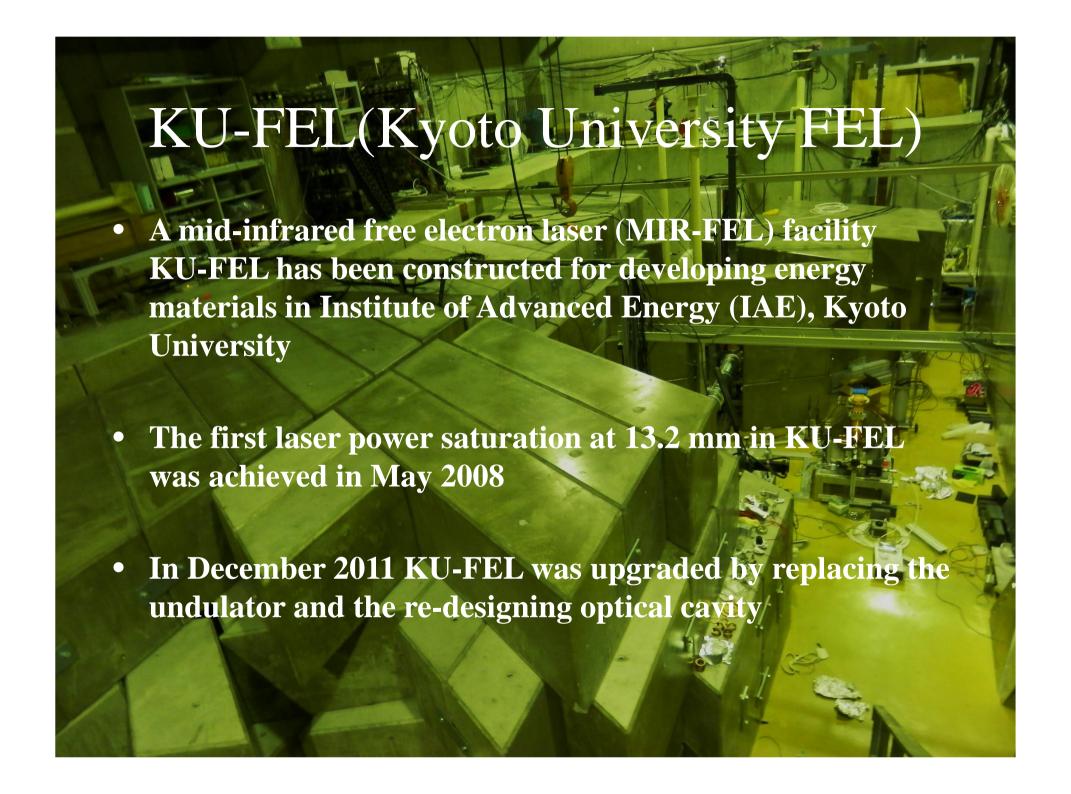


Institute of Advanced Energy, Kyoto University

KU-FEL Facility

Status Report

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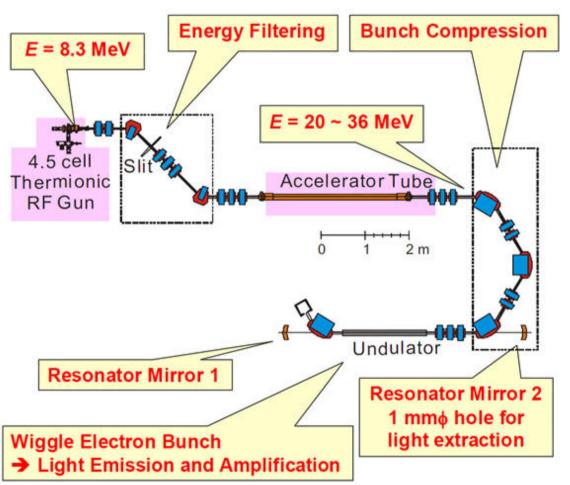
Measurement System Facility Construction

Summary

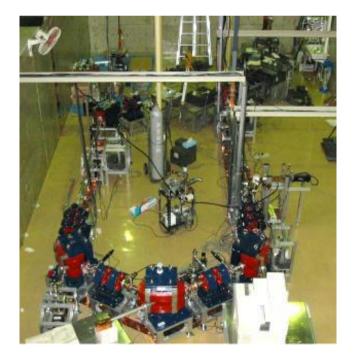


KU-FEL Structure





Mid Infrared Oscillator type FEL

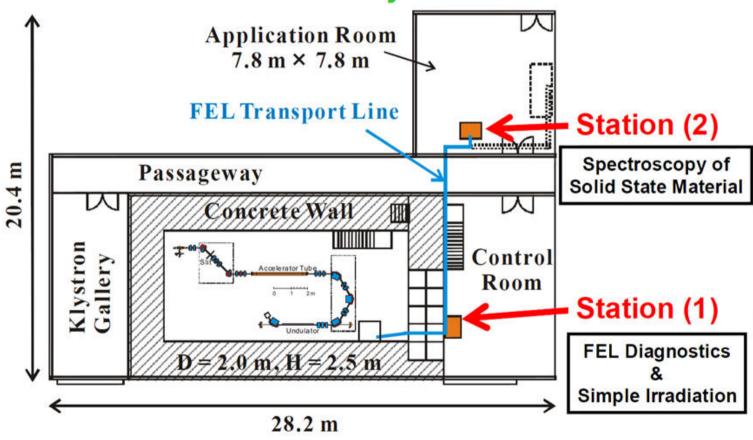




FEL Hall

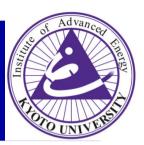


Two user stations are ready for use.

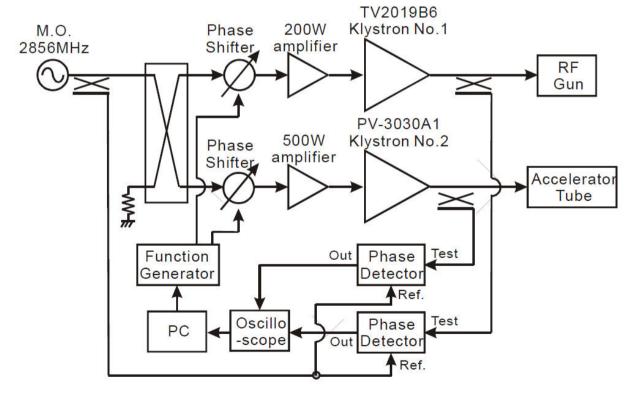




Schematic Diagram of RF-System in KU-FEL



There are two different Klystrons used to supply RF-gun(10MW) and Accelerator(20MW). RF system including two voltagecontrolled phase shifters to measure and compensate the phase shift.





RF Gun

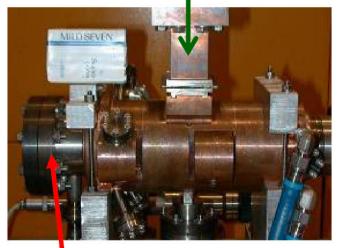


drive rf power < 10 MW

2.856 GHz

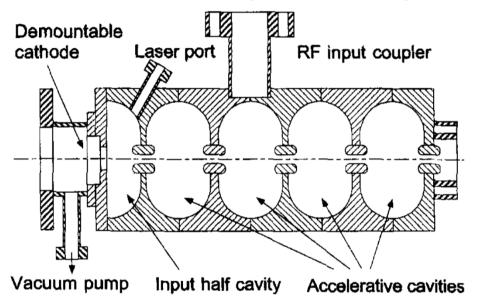
<10 µsec

<10 Hz



thermionic cathode mount

4,5 cell thermionic RF gun for IR FEL generation



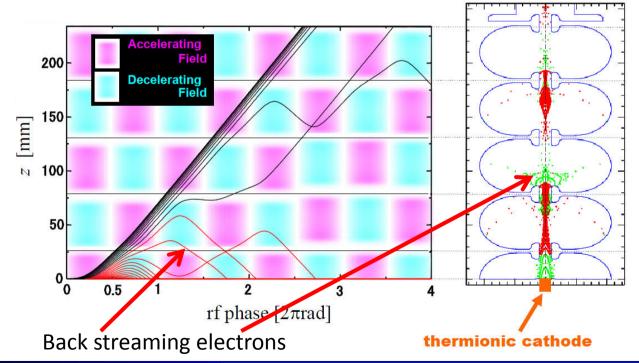
The electron beam is produced by a LaB6 thermionic cathode of 2 mm diameter. A transverse magnetic field of about 10 G on the cathode surface is applied to divert backstreaming electrons



Back Bombardement Effect



- BB effect: some electrons are "drifting" into the deccelerating rf-phase, which accelerates them back to the cathode. The back streaming electrons hit the cathode and increase its temperature
- 1-D simulation of back streaming electrons for 4.5 cell thermionic rf gun





Ramping Current



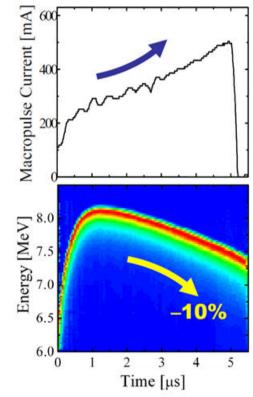
Back streaming electrons heat the cathode

Surface temperature rises

Beam current increases

Beam loading increases

Beam Energy decreases



Macropulse duaration decreases



Beamloading Compensating Methods

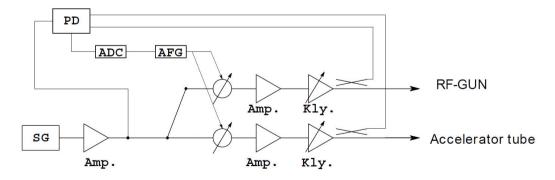


- The FEL saturation is achieved after application of measures to mitigate the beam loading increase due to BBE (back bombardement effect)
- Amplitude modulation method

In order to stabilize the electron beam energy amplitude-modulated RF pulses are applied to the RF gun and accelerator. This method causes phase shift, which is compensated by electrical phase shifters

Cavity detuning method

In order to increase the gain the RF power is applied to the electron gun with slightly higher frequency (290 kHz) than the resonance

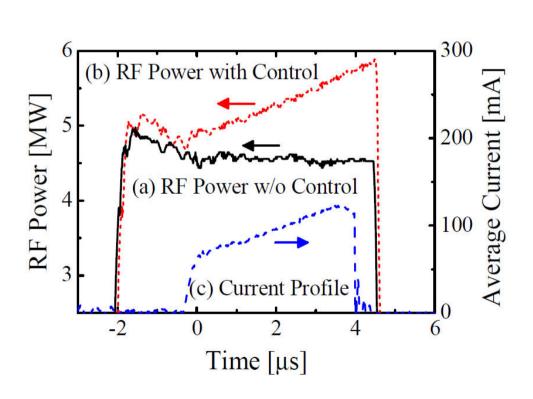


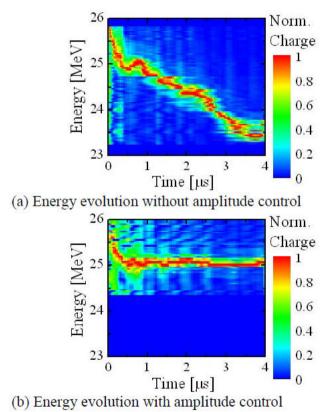


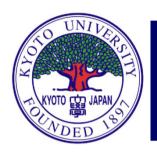
Amplitude Modulation Method



Modification of RF amplitude compensates for energy drop of electron beam





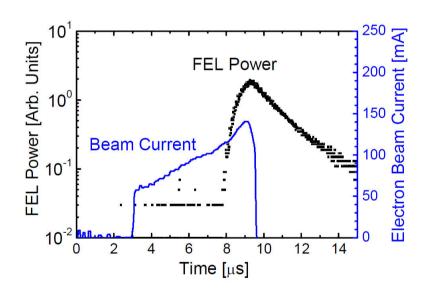


Electron Beam Properties



The Back Bombardement Effect causes additional heating of the cathode material, which increases the current with time. The ramping current limits the FEL pulse duration.

Electron beam properties of KU-FEL		
Energy Spread (FWHM)	~3 %	
Peak Current	~40 A	
Normalized Emittance	3.5, 12 π mm-	
(x and y)	mrad	
Macro-pulse Duration	7.2 μs	
Ramping current due to BB effect		
Macropulse current	~100 mA	
Bunch Length (FWHM)	2.0 ps	





Undulator and Cavity

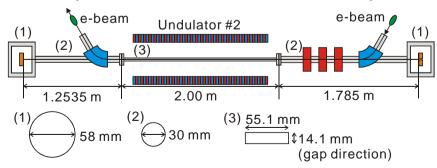


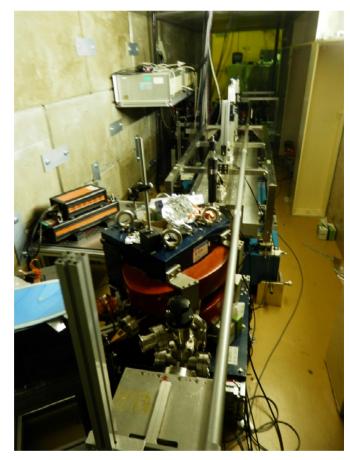
Parameters undulator which had already been used for ERL-FEL in JAEA.

Undulator #2 (from Dec. 2011)		
Structure	Hybrid	
Period length	33 mm	
Number of periods	52	
Maximum K-value	1.05*	
Minimum Gap	20 mm*	

^{*}with present vacuum chamber. Mechanical limit of the minimum gap is 15 mm. Then K-value will be higher than 1.5.

Geometry of the undulator and cavity mirrors.





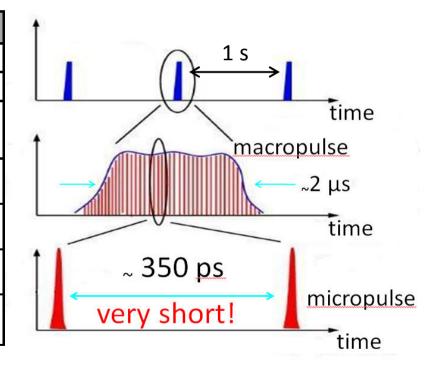


FEL Parameters



FEL radiation consists of macro-pulse and micro-pulse corresponding to electron beam structure. The macro-pulse is released with 1 Hz repetition rate. Each micro-pulse contains 5700 micropulses

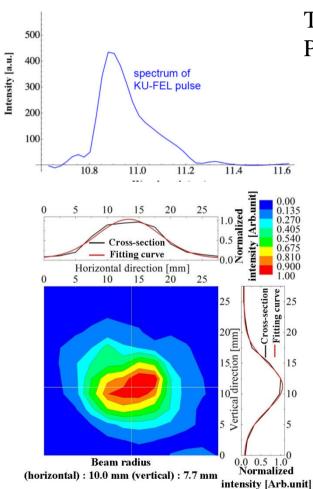
Mid infrared oscillator FEL		
Wavelength range	$5-14.5 \mu m$	
Peak power	~4 MW	
Macro-pulse	~ 2 \mu s (@10\mu m)	
duration		
Macro-pulse energy	$1 - 15 \text{ mJ (max.@ 10 } \mu\text{m})$	
Macro-pulse power	5 kW	
Micro-pulse energy	0.5-2.5 μJ	
Micro-pulse duration	< 0.66 ps @ 12 μm	



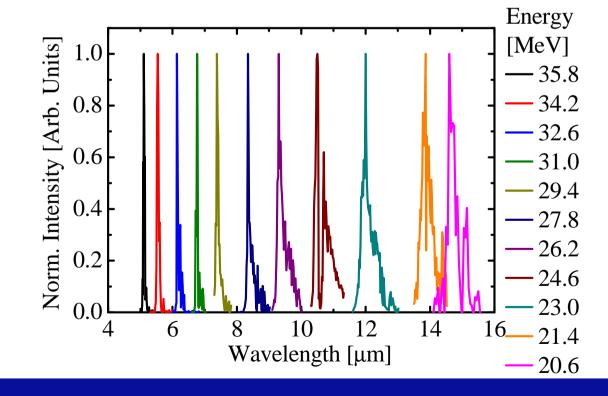


FEL Spectral Characteristics





The wavenumber of FEL is adjusted by changing e-beam energy Present Tunable Range : 650-2000~cm-1 : $5-14.5~\mu m$





Application for Material Science



Main Project: Investigation of the relation between lattice vibration (phonon) and electronic structure by wide gap semiconductors (SiC, TiO2). We use photo luminescence spectroscopy in combination with selective phonon excitation by MIR-

FEL.

Si-C: 12.6 μm Si-H: 11.2 μm Si-N: 10.4 μm Si-O: 9.8 μm

Selective Phonon Excitation

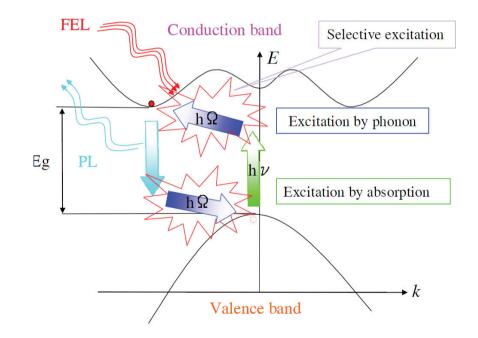
MIR-FEL(KU-FEL) for selective phonon excitation



Photoluminescence (PL) measurement system for observation of electronic structure



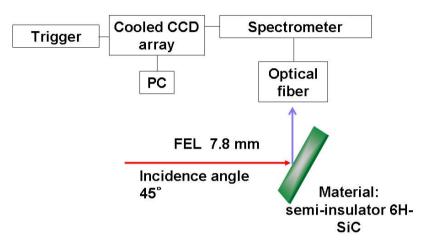
Analysis the relation between a specific phonon mode and electronic structure





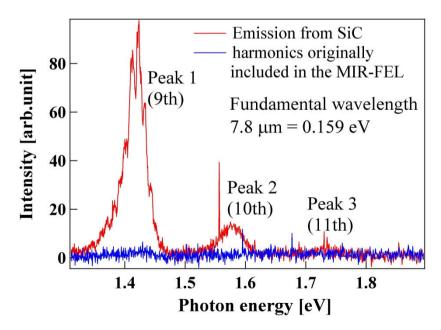
Application for HHG Investigation





Measurement condition

Wavelength	7.8 μm (0.159 eV) 8.6 μm (0.144 eV)
Macro-pulse power	
Macro-pulse width	2 μs
Repetation rate	1 Hz





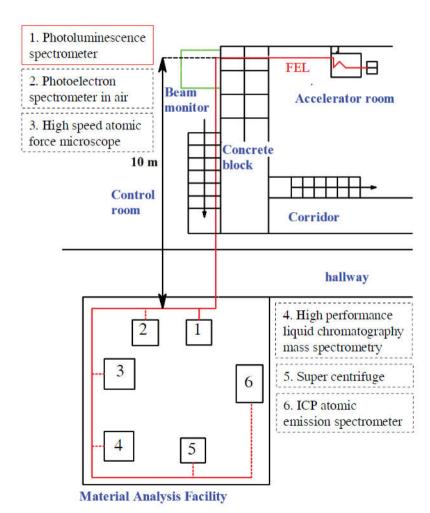
Further Development of Measurement system



The FEL radiation will be provided to 6 different experimental systems:

- Photoluminescence (PL) spectrometer(already present)
- Photoelectron spectrometer in air
- *High speed atomic force microscope*
- High performance liquid chromatography mass spectrometry
- Super centrifuge
- *ICP atomic emission spectrometer*

The measurement systems will be applied for investigation of candidate materials for electrode of solar cells, a next generation materials for power devices, and photocatalytic mater.

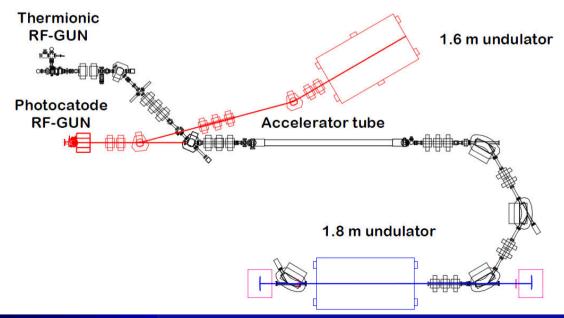




Further Development Facility Construction



- **Beam stability improvement**: Currently a beam position and energy stabilization is under development. This system uses amplitude information from the BPMs and a bunch phase stabilization system
- **Electron beam improvement-** The thermionic RF gun shall be modified to triode type in order to mitigate the electron back bombardment effect
- THz FEL amplifier A new construction for a THz FEL amplifier is planned

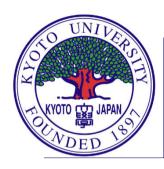




Summary



- MIR FEL facility in Kyoto University is now ready for use
- Tunable Range : $650 2000 \text{ cm} 1 (5 14.5 \mu\text{m})$
- Electron beam feedback control system is under development
- Photocathode system will be installed
- PL spectroscopy system with MIR-FEL is ready for phonon-electron interaction study in semiconductors.
 Other user stations are under construction



KU-FEL Group



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ご清聴ありがとうございました (Danke für Ihre Aufmerksamkeit)

